

Notice of References Cited	Application/Control No. 10/796,201		Applicant(s)/Patent Under Reexamination SEGAWA ET AL.	
	Examiner DANIEL C. MCCracken		Art Unit 1793	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,676,913	10-1997	Cirillo et al.	423/219
*	B	US-5,221,520	06-1993	Cornwell, James H.	422/122
*	C	US-5,538,697	07-1996	Abe et al.	422/171
*	D	US-2002/0016252	02-2002	TAKAHASHI et al.	502/71
*	E	US-5,142,864	09-1992	Dunne, Stephen	60/274
*	F	US-5,497,619	03-1996	Yamada et al.	60/279
*	G	US-6,042,637	03-2000	Weinberg, Stanley	96/58
*	H	US-4,661,468	04-1987	Lee et al.	502/333
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Heck, et al., The application for monoliths for gas phase catalytic reactions, Chemical Engineering Journal 2001; 82: 149-156			
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.